

SiWDESY201706MIP45 < CALICE < TWiki

In parallel to the magnetic field tests and setup, we decided to take a run with the detector tilted ~45 degrees to increase the cross section of the silicon wafer traversed by MIP-acting electrons. You can see the diagram of the new position in the attachment. We kept all layers inside the stack except the first one (slab 21) moved to the magnetic field area.

-- AdrianIrles - 2017-10-10

This topic: CALICE > SiWDESY201706MIP45

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